

00862.023188.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
AKIHIRO MATSUYA)	Examiner: Shewaye Gelagay
)	
Application No.: 10/646,797)	Art Unit: 2437
)	
Filed: August 25, 2003)	Confirmation No.: 1223
)	
For: IMAGE PROCESSING SYSTEM AND)	
AUTHENTICATION METHOD)	
OF THE SAME)	January 19, 2010
		(Tuesday after a federal holiday)

Mail Stop: Issue Fee
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

STATEMENT OF SUBSTANCE OF INTERVIEW

Sir:

This Statement is being filed in response to the Interview Summary dated December 16, 2009. The Interview Summary refers to the interview between the Examiner and Applicant's undersigned representative on December 2, 2009. Applicant concurs with the Examiner's summary of the interview as presented in the Interview Summary.

It is believed that this response, in conjunction with the Interview Summary issued by the Examiner, represents a complete written statement as to the substance of the interview, in accordance with M.P.E.P. § 713.04.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our listed address below.

Respectfully submitted,

/Lock See Yu-Jahnes/

Lock See Yu-Jahnes
Attorney for Applicant
Registration No. 38,667

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